PATENT

DOCKET NO.: 1834-2

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

APPLICANT:

Kim et al.

SERIAL NO. :

not yet assigned

FILED

simultaneously herewith

TITLE

APPARATUS AND METHOD FOR MEASUREMENT OF FILM

THICKNESS USING IMPROVED FAST FOURIER

TRANSFORMATION

PRELIMINARY AMENDMENT

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Dear Sir:

Preliminary to the initial Office Action, please amend the above-identified application as follows: